

Introduction

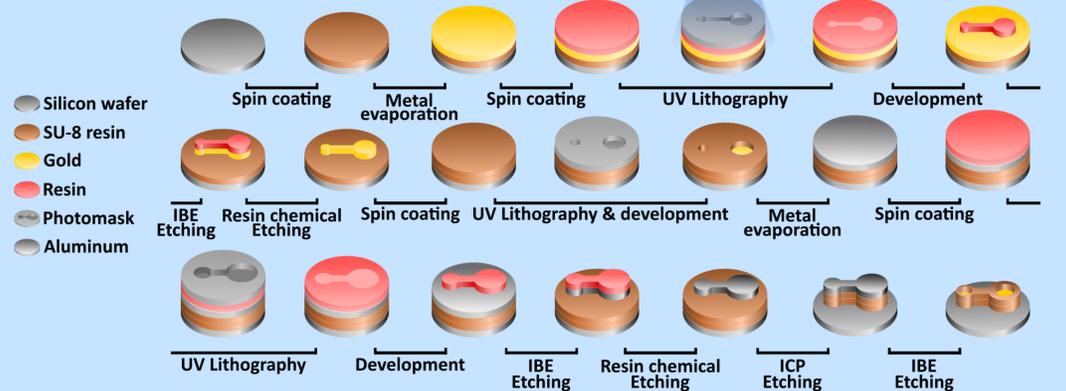
Neuroengineering more efficient neural interfaces is crucial to develop better clinical rehabilitation solutions and for neural network exploration. Most of current intra-cortical implants are stiff and generate mechanical strain that results in complex cellular responses and instabilities in neural signal recording.

Designing soft intra-cortical neural implant with a high density microelectrode array has therefore become essential to faithfully record several neural units overtime and to facilitate for instance, brain computer interface performances and the study of memory and plasticity.

We developed a soft SU-8 polymer neural implant with 64 nanostructured gold 20µm electrodes and varied the design of the 2mm deep intra-cortical part of the implant. Leads were either 50µm, 20µm or 11µm wide with a straight or a wavy shape. In vivo biocompatibility tests in rodents were performed, astrocytes and microglia were first analyzed around a 12µm thick SU-8 implant.

3 - Process

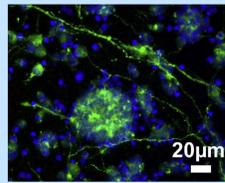
Clean room processes were used to fabricate the implant. It allows to create thin layers (implants were made of 200 nanometers of gold between two 4µm SU-8 layers) and pattern accurate shapes.



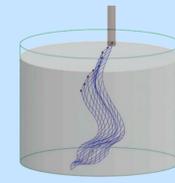
1 - Goal

Our objective is to create a new implant answering to the following requirements:

- 1) Neuron-sized
- 2) Flexible
- 3) Implantable
- 4) Easy to connect



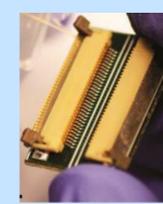
Piret et al, 2013



Zhou et al, 2017



Tien et al, 2013

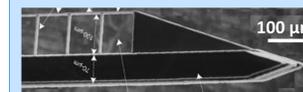


Schuhmann et al, 2017

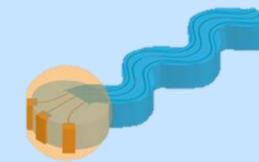
2 - Design

The implant design aims at combining the following characteristics:

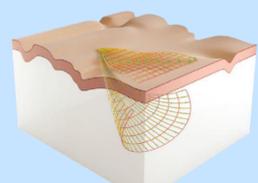
- 1) Low dimension for neuron repopulation
- 2) Wavy shape for brain movement absorption
- 3) Wires to be free of mechanical strains



Seymour, J. P et al. 2007
Karumbaiah, L et al 2013



Sohal et al. 2014

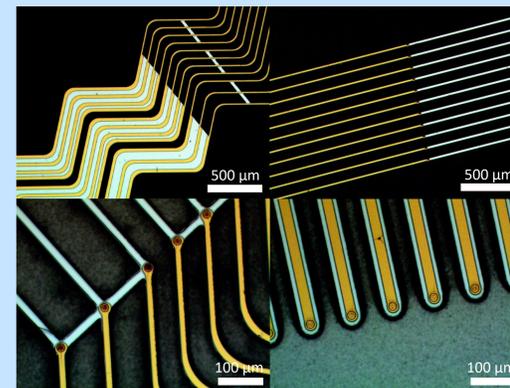


Liu et al. 2015

4 - Implant imaging

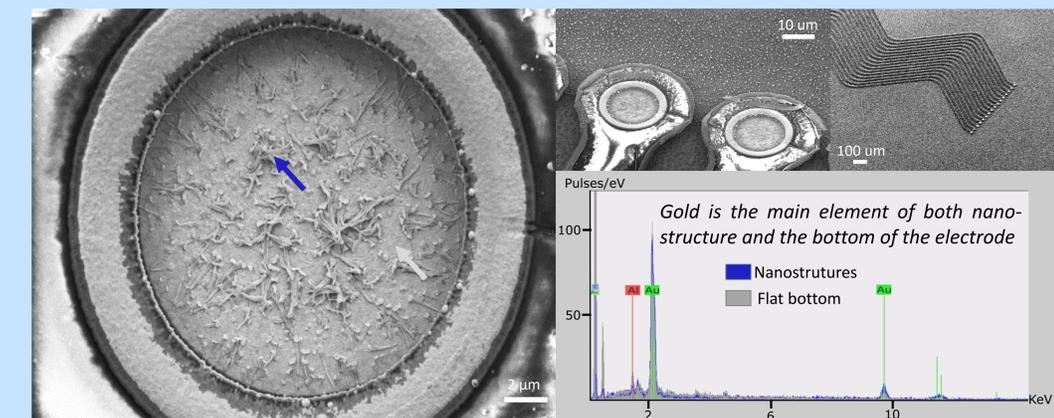
Microscope images

Different patterns compose the implant that is made of either wavy or straight wires of either 11 or 20 or 50 µm width. All electrodes have a 20 µm diameter. Similarly to a spring, wavy shapes should absorb movement from brain beating.

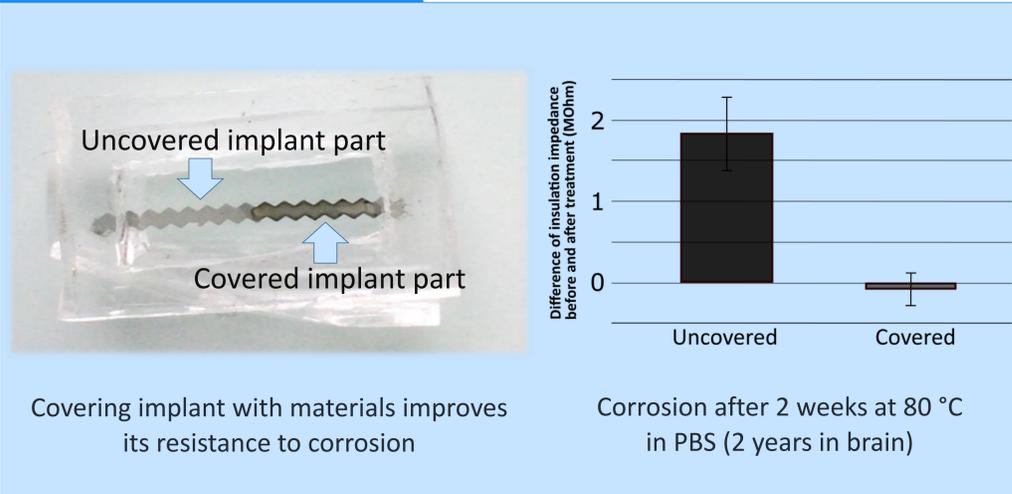


MEB images

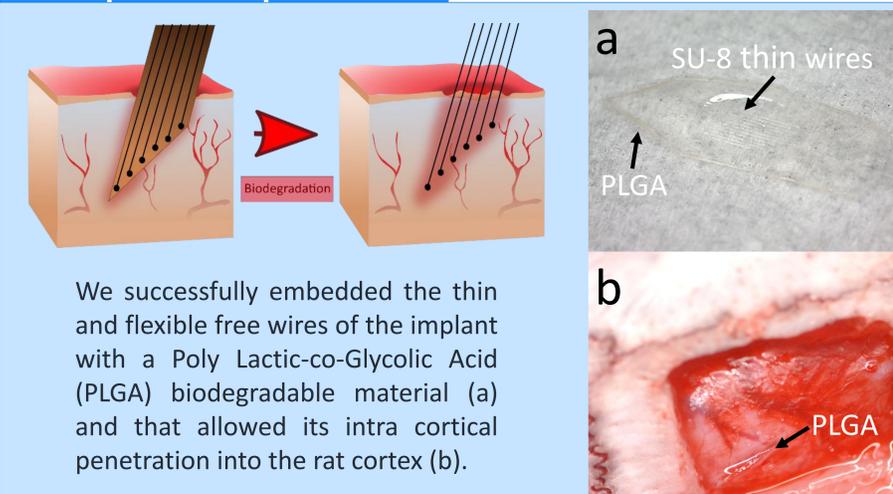
We could form nanostructured gold electrodes using ion beam etching (IBE), the last step of the clean room process. Nanostructures have been shown to improve neuron adhesion (Piret et al, 2013) and neural recording performances (Piret et al, 2015).



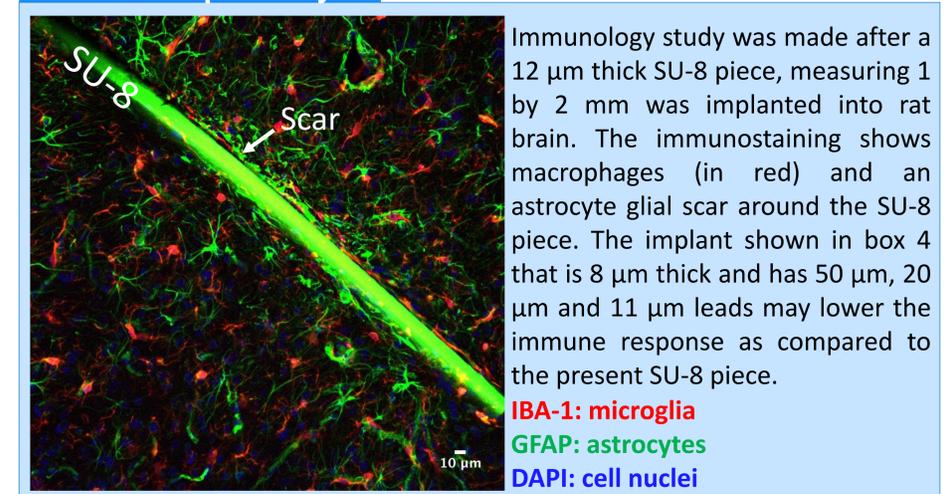
5 - Insulation resistance



6 - Implant encapsulation



7 - Biocompatibility



Conclusion and perspectives

The principal assets of this new implant that we fabricated are : 1) the small size 2) the thickness of the implant (thin enough to lower inflammation and thick enough to better resist to corrosion in time) 3) that each electrodes are not linked to each other and could intracortically inserted. 4) High microelectrode density. Next steps are to study the long term biocompatibility of the implant and to perform neural recording.